



FORM PTO-1449		US Dept. of Commerce Patent and Trademark Office		ATTORNEY DOCKET NO. ATMI-520		SERIAL NO. 09/935,805	
INFORMATION DISCLOSURE STATEMENT (use several sheets if necessary)				APPLICANT Ying Ma, et al.			
				FILING DATE August 23, 2001		GROUP 1763	
U.S. PATENT DOCUMENTS							
EXAMINER INITIAL		PATENT NUMBER	ISSUE DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
gag	AA	5,770,095	6/23/1998	Sasaki, et al.			
FOREIGN PATENT DOCUMENTS							
		DOCUMENT NUMBER	PUBLICATION DATE	COUNTRY	CLASS	SUBCLAS S	TRANSLATION YES NO
							X (abstract only)
OTHER DOCUMENTS (Including Author, Title, Journal-Date, Page Number, Etc.)							
gag	AB	Hayashi, et al., A New Abrasive-Free, Chemical-Mechanical-Polishing Technique for Aluminum Metallization of ULSI Devices, IDEM, 1992, pages 976-978.					
Continue on Page							
EXAMINER George A. Goudreau					DATE CONSIDERED 1-04-01		
EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP § 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to the applicant.							